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**CENTRAL FAX CENTER**U.S. Application No. 10/752,642  
Reply to Office Action mailed November 2, 2006**DEC 29 2006****PATENT**  
**790001-2042****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Naofumi Nakamura et al.  
Serial No. : 10/752,642  
For : SEMICONDUCTOR DEVICE AND METHOD OF  
FABRICATING THE SAME  
Filing Date : January 7, 2004  
Examiner : Jesse A. Fenty  
Group Art Unit : 2815  
Confirmation No. : 4109

**FACSIMILE**I hereby certify that this paper is being facsimile transmitted to the  
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person signing certificationBernadette Vassallo

Signature

December 29, 2006

Date of Signature

OK to Enter  
JFY 03/19/07745 Fifth Avenue  
New York, NY 10151**RESPONSE****MAIL STOP AMENDMENT**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This response is submitted in reply to the Final Office Action in the above-captioned  
application mailed on November 2, 2006, having a three-month statutory period for response set  
to expire on February 2, 2007, Applicants respond as follows.